

(Use several sheets if necessary)

NEC NEL-542

10/718,848

ONO

November 21, 2003

2891

[illegible]

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
SW		09-064049	07.03.1997	JAPAN (w/Abstract)	H01L	21/321		✓
I		11-135549	21.05.1999	JAPAN (w/Abstract)	H01L	21/60		✓
I		2001-024085	26.01.2001	JAPAN (w/Abstract)	H01L	23/12		✓
SW		2001-203297	27.07.2001	JAPAN (w/Abstract)	H01L	23/12		✓

Christen Wilson

4/5/05

SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

2148 0 3 2003

Docket Number (Optional) NEC NEL-542		Application Number 10/718,848
Applicant(s) ONO		
Filing Date November 21, 2003		Group Art Unit 2812 2891

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
sw		2002-110854	4.12.02	JAPAN (w/abstract)	H01L	23/12		✓
		2001-250876	9.14.01	JAPAN (w/abstract)	H01L	23/12		✓
		10-032224	2.3.98	JAPAN (w/abstract)	H01L	21/60		✓
		10-335528	12.18.98	JAPAN (w/abstract)	H01L	23/12		✓
sw		2000-223647	8.11.00	JAPAN (w/abstract)	H01L	25/04		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER <i>Christian Wilson</i>	DATE CONSIDERED <i>4/5/05</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.